



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Minjuan ZHANG et al.

Serial No. 09/874,066

Filed June 6, 2001

METHOD AND SYSTEM FOR
FORMING COPPER THIN FILM

: Confirmation No. 5653

: Docket No. 2001_0712A

: Group Art Unit 1762

: Examiner Timothy Howard MEEKS

RECEIVED
AUG 21 2003
TC 1700

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a one month extension of time to respond to the communication of
April 17, 2003.

The fee of \$110.00 is

(X) submitted herewith.

0 to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is
enclosed.

0 Small entity status of this application is established by a Small Entity Status Assertion
which

0 is enclosed.

0 has been previously submitted.

Respectfully submitted,

Minjuan ZHANG et al.

By

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August 18, 2003

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